| Count | Query | Databases |
|---|---|---|
| 1 | 200500121165 | US-PGPUB; USPAT |
| 29 | (((((glass adj substrate) and (silicon with (gnd or ground or grounded)))) and . | US-PGPUB; USPAT |
| 32 | (((((glass adj substrate) and (silicon with (gnd or ground or grounded))) and . | US-PGPUB; USPAT |
| 0 | S112 and (mem or accelerometer) | US-PGPUB; USPAT |
| 0 | S114 and (mem or accelerometer) | US-PGPUB; USPAT |
| 9 | 5349858 | US-PGPUB; USPAT |
| 8 | S116 and silicon | US-PGPUB; USPAT |
| 22 | ((glass or ceramic) with substrate) and S121 | US-PGPUB; USPAT |
| 8 | S122 and static | US-PGPUB; USPAT |
| 14 | (((glass with substrate) and shield and (((sensor or sensing) not (image or li | US-PGPUB; USPAT |
| 3 | ((glass or ceramic) with substrate) and (((sensor or sensing or actuator) not | US-PGPUB; USPAT |
| 12 | S127 and potential | US-PGPUB; USPAT |
| 11 | S128 not memory | US-PGPUB; USPAT |
| 32 | S130 and silicon | US-PGPUB; USPAT |
| 31 | S131 not memory | US-PGPUB; USPAT |
| 15 | S122 and (static or electrostatic) | US-PGPUB; USPAT |
| 1 | ((glass or ceramic) with substrate) and (((sensor or sensing or actuator) not | EPO; JPO; DERWENT |
| 17 | S132 and (sensor or sensing or actuator or accelerometer) not | EPO; JPO; DERWENT |
| 11 | S133 and (static or electrostatic) | US-PGPUB; USPAT |
| 2 | S133 and (static or electrostatic) and corner | US-PGPUB; USPAT |
| 4 | 257/665.ccls. and (static or electrostatic) and corner | US-PGPUB; USPAT |
| 8 | S137 and (corner with (gnd or ground or grounded)) | US-PGPUB; USPAT |
| 1 | S137 and (corner with (hole)) | US-PGPUB; USPAT |
| 6 | (glass with substrate) and (@ad<"20040227" or @rlad<"20040227") and (c | US-PGPUB; USPAT |
| 1 | 20040053465.did. | US-PGPUB; USPAT |
| 1 | S140 and (@ad<"20040227" or @rlad<"20040227")) | US-PGPUB; USPAT |